



**ELECTRONIC COPY**

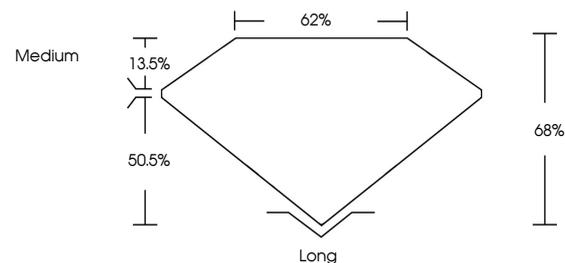
LG668410116  
Report verification at igi.org



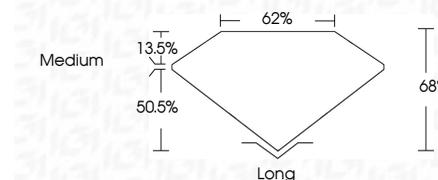
February 17, 2025  
IGI Report Number **LG668410116**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **EMERALD CUT**  
Measurements **9.10 X 5.87 X 3.99 MM**  
**GRADING RESULTS**  
Carat Weight **2.15 CARATS**  
Color Grade **F**  
Clarity Grade **VS 1**

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**PROPORTIONS**



Sample Image Used



**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG668410116**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

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**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

| IF                  | VS <sup>1-2</sup>           | VS <sup>1-2</sup>      | SI <sup>1-2</sup> | I <sup>1-3</sup> |
|---------------------|-----------------------------|------------------------|-------------------|------------------|
| Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included         |



**IGI**

February 17, 2025  
IGI Report No **LG668410116**  
**EMERALD CUT**  
**9.10 X 5.87 X 3.99 MM**  
Carat Weight **2.15 CARATS**  
Color Grade **F**  
Clarity Grade **VS 1**  
Depth **68%**  
Table **62%**  
Girdle **Medium**  
Culet **Long**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG668410116**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa